

Substitute for form 1449A/PTO (modified)

Application Number

10/665,761

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Filing Date

September 19, 2003

First Named Inventor

Jing, Naiyong

Art Unit

1733

Examiner Name

Attorney Case Number

56210US005

(Use as many sheets as necessary)

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Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
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JM	C2	Appl. Phys. Lett., Vol. 63, No. 25, December 20, 1993, "Surface Modification and Metallization of Fluorocarbon Polymers by Excimer Laser Processing", H. Niino and A. Yabe

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JK

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9/15/05

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<i>TH</i>	A1	US- 6,752,894 B2	06/22/2004	Jing et al	

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